



BEST AVAILABLE COPY

Docket No.: 15675P326

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

ANDRE LEYCURAS

Application No.: 09/601,109

Filed: October 16, 2000

For: **CHEMICAL VAPOR DEPOSITION REACTOR  
AND PROCESS**

Art Group: 1762

Examiner: Bret P. Chen

#8  
Hedley  
6/27/02

**PETITION FOR EXTENSION OF TIME PURSUANT TO 37 C.F.R. § 1.136(a)**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In accordance with 37 C.F. R. § 1.136(a), Applicant for the above-identified application respectfully Petitions the Commissioner for a one (1) month extension of time, extending the period for response to June 13, 2002, from the Final Office Action dated February 13, 2002. The petition filing fee of \$110.00 and a Request for Continued Examination (RCE) are attached.

If it should be determined that a longer extension of time is required to prevent this application from being abandoned, please charge any additional fees to Deposit Account No. 02-2666. A copy of the Fee Transmittal is enclosed for deposit account charging purposes.

COPY OF PAPERS  
ORIGINALLY FILED

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Date: June 13, 2002

Eric S. Hyman, Reg. No. 30,139

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TC 1700

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I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class mail with sufficient postage in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on: June 13, 2002

Lillian E. Rodriguez

06-13-02  
Date